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PATENT APPLICATION

3654-280 #3
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IDS
MAN
4/30/01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

SEIJI MISHIMA

Application No.: 09/694,268

Filed: October 24, 2000

For: METHOD OF MANUFACTURING
ELECTRONIC DEVICE,
ELECTRON SOURCE
SUBSTRATE, AND IMAGE
FORMING APPARATUS, AND
APPARATUS FOR
MANUFACTURING ELECTRONIC
DEVICE AND ELECTRON
SOURCE SUBSTRATE

Examiner: Not Yet Known

Group Art Unit: NYA

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November 28, 2000

Commissioner for Patents
Washington, D.C. 20231

INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under
37 C.F.R. § 1.56 and in accordance with the practice under
37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is
directed to the documents identified on the enclosed Form
PTO-1449. Copies of the documents are also enclosed,

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together with a copy of February 24, 1999, PCT Search Report citing them.

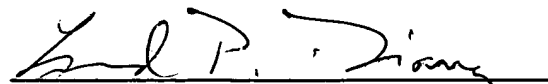
For the concise statement of relevance of the listed documents, which are non-English, the Examiner is respectfully referred to the English Abstracts attached thereto.

CONCLUSION

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Applicant's undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our below listed address.

Respectfully submitted,


Attorney for Applicant

Registration No. 78,286

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